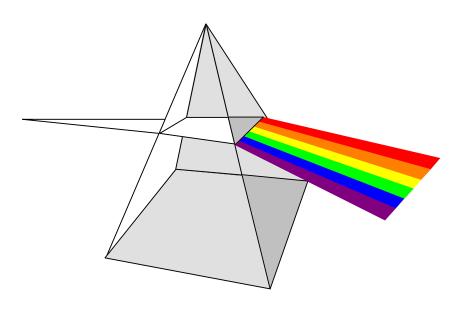


New Developments for MCS 500





New Basic Developments recently introduced

- MCS 511 NIR Family
- OMK 500 H NIR
- Film Control Low Cost Thickness Measurement System
- Measuring Head for Low Reflection Coating 10°/10°



New Software Developments soon available

- MCS 500 Driver for GRAMS® Software Package
- Driver to run cascaded MCS501/551 in Double Beam Mode



Recently finished and current Projects

On-Line Measurement of Low-reflection Coatings on CRT

Company LEYBOLD Installations in Wales(finished) and Japan(Nov. 98)

In-Line Measurement of vacuum-coated foils

Company LEYBOLD Installation in Switzerland (Nov. 98)

• In-Line Measurement and Quality Control of coated Glass

Company LEYBOLD Installation in France (Oct. 98)



Recently finished and current Projects

- Colour Measurement of PE-Coating on Photo Paper Company FUJI Netherlands 10/98
- Aromatics in Water
 Company DOW/PSL Netherlands/Germany
- Measurement of Fat, Protein, Moisture in Meat Company Reichert/Schnell GmbH 10/98



Recently finished and current Projects

- On-Line Control of Production of "Bio-Diesel" / NIR LUT Germany 11 / 98
- Reflection of Lamp Bulbs (380 1700 nm)
 Auer GmbH / Germany 9/98
- In-Line Measurement of sugar and alcohol in filling plants
 Diessel Germany Test



Spectrometer System MCS 511 NIR



MCS 511 NIR with OMK500

- Polychromator MMS NIR
- 950 1700 nm (6nm/diode)
- 1400 2200 nm (in Prep.)
- 1000 2400 nm (in Prep.)
- Compatible with MCS500
 Familiy
- Cascadeablewith all MCS500



Spectrometer System MCS 511 NIR

| Wavelength range | 950 - 1700 nm (InGaAs, cooled) 1400 - 2200 nm (ext. InGaAs, cooled) 1000 - 2400 nm (ext. InGaAs, cooled) |
|---------------------|--|
| | |
| Wavelength accuracy | < 0,6 nm |
| Wavelength Reprod. | < 0,1 nm |
| Resolution | 6 nm/ diode (18 nm acc. Rayleigh) |
| Absorption Range | 0 3 AU |
| Linear Range | 02 AU (With Blocking Filter RG1000) |
| Stray Light | < 0,1 %T measured at water band with blocking filter (RG850) |
| Noise | < 1 mAU (1sec. Measurement Time) |



Spectrometer System MCS 511 NIR

| AD-Converter | 15/16 bit |
|-------------------|---|
| Interface | RS 422 (serial, 20 Mbit/sec) |
| Transfer distance | Appr. 80 m (Standard) Appr. 2500 m (Fiber cable) |
| Housing | 19" Standard incl Lamp 19" Protective housing IP65 19" Plug-in Rack 9,5" Housing (without lamp) |



Applications of MCS 511 NIR

Food Industry

Glass Industry

Forage Research

Pharmacie





Spectrometer System MCS 511 NIR Software

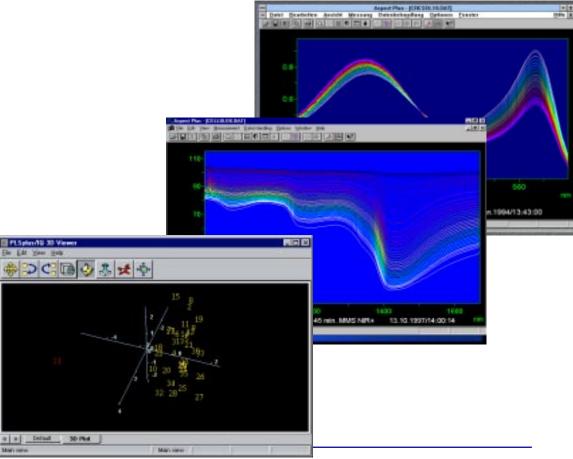
ASPECT PLUS

Customer-tailored Software

GRAMS[®] 32

LabView Library

C - Library





Spectrometer System MCS 511 NIR

Integrating Spheres

Reflection Head OMK 500

Diffuse Reflection Probes

Optical Multiplexer (2..16 channels)

Accessories





Spectrometer System MCS 511 NIR

SMA Optics

Cell Holder

Immersion Probes





Spectrometer System MCS 511 NIR

Reflection Head OMK 500 NIR

Wavelength Range Geometrie Light Source Life Timeof lamp Power Source

Fiber Connector

400 - 2400 nm 0°/45°(circular) Tungsten lamp > 5000 h 5 V/2A

ZEISS





Measurement System for Low-Reflection Coatings



Optimized for CRT

Geometrie 10°/10°

High Attenuation of back Reflection

Automatic version with integrated Calibration Set available



Reflection Handy Head 10°/10°

| Measurement of low reflect on glass surfaces | ting coatings |
|--|---|
| 10° / 10 ° | |
| 360 - 2000 nm | |
| 2 mm | |
| 2 x ZEISS | 200 |
| | on glass surfaces 10° / 10° 360 - 2000 nm 2 mm |



Film Control - Thickness Measurement System



Single Layer Coatings

Range 1 - 30 um

FFT Algorithm

Integrated PC

Tungsten Light Source



Film Control - Thickness Measurement

Thickness Range

Principle Polychromator Light Source Electronic unit

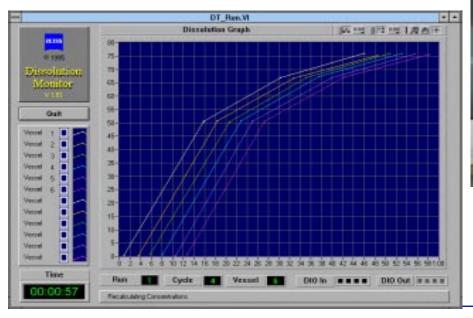
Accessories

1 - 30 um (optical thickness)
Single Layer
White light interference
MMS1
Tungsten, 5V/8W
Integrated PC
14-bit electronic unit
Y - Light guide
SMA Optic



MultiChannel Dissolution System ZDIS-MUX

MCS 551UV / CLD500 8-Channel MUX Immersion Probes





LabView[®] based Software